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PATENT

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re Application of:

Anne E. Miller et al.

Serial No.: 09/715,282

Filed: November 16, 2000

For: SLURRY AND METHOD FOR CHEMICAL  
MECHANICAL POLISHING OF COPPER

Mail Stop ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Examiner: Chen, Kin Chan

Art Unit: 1765

**SUBMISSION OF FORMAL DRAWINGS**

Dear Sir:

Enclosed herewith for submission in the United States patent application referenced above are three (3) sheets of formal drawings.

If there are any further charges please charge them to Deposit Account No. 02-2666.

Respectfully submitted,  
BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: 1/27, 2004

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1/27/2004  
Date